



PATENT  
NPO0005-01

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GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group  
Art Unit: 1762  
  
Attorney  
Docket No.: NPO0005-01  
  
Applicant: Keiji Ishibashi  
  
Invention: A HOT ELEMENT CVD  
APPARATUS AND A  
METHOD FOR REMOVING  
A DEPOSITED FILM  
  
Serial No.: 09/633,002  
  
Filed: August 4, 2000  
  
Examiner: W. Markham

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS correspondence  
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to: Assistant Commissioner for Patents, Washington,  
D.C. 20231, on: April 7, 2003

ANTHONY NIEWYK, REG. NO. 24, 871

Name of Registered Representative

Signature

April 7, 2003

Date

AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Responsive to the Office Action dated December 10, 2002, which had a period for  
response set to expire on March 10, 2003, which period has been extended by the enclosed  
Petition For Extension Of Time to expire on April 10, 2003, Applicant hereby submits the  
following amendment: